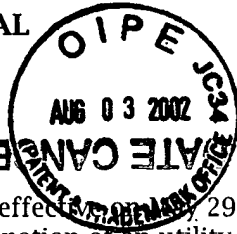


#13
#14/08



REQUEST
FOR
CONTINUED EXAMINATION (RCE)
TRANSMITTAL

BOX RCE
Commissioner of Patents
Washington, D.C. 20231



Subsection (b) of 35 U.S.C. § 132, effective September 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995

Application Number	09/672,776
Confirmation Number	2256
Filing Date	September 29, 2000
First Named Inventor	Fumiyoshi ONO
Group Art Unit	1765
Examiner Name	Charlotte A. Brown
Matter Number	Q61045
Title	COMPOSITION FOR POLISHING METAL ON SEMICONDUCTOR WAFER AND METHOD OF USING SAME

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

1. SUBMISSION REQUIRED UNDER 37 C.F.R. § 1.114

- a. ☒ Previously submitted
- i. ☒ Please enter and consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on July 3, 2002
- ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____
- iii. ☐ Other _____
- b. ☒ Enclosed
- i. ☐ Amendment/Reply
- ii. ☐ Affidavit(s)/Declaration(s)
- iii. ☐ Information Disclosure Statement (IDS)
- iv. ☒ Petition for Extension of Time
- v. ☐ Other _____

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2. MISCELLANEOUS

- a. ☐ Suspension of action on the above-identified application is requested under 37 C.F.R. § 1.103(c) for a period of _____ months
- b. ☐ Other _____

3. FEES

A check for the RCE statutory fee of \$740.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.

SIGNATURE OF ATTORNEY

Name	<u>Keiko K. Takagi</u>	Registration No.	<u>47,121</u>
Signature	<u>Keiko K. Takagi / Bruce E. Crane</u>	Date	<u>September 3, 2002</u>